Microstructuring glass surfaces using a combined masking and microslurry-jet machining process

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ABSTRACT

The combined application of a conventional photoresist masking process and microslurry-jet (MSJ) mechanical removal process was studied for microstructuring the surface of glass. Masking patterns made of a photocurable resin (SU-8) were created on the glass, and both the SU-8 patterns and exposed glass surface were simultaneously removed using the MSJ. When the sacrificial patterns of the SU-8 were removed by the MSJ, the glass surface with microstructures was created. Post-treatment, such as removal of the SU-8 patterns, was not required. Confocal microscopy results confirmed that continuously curved convex structures up to 30 µm in diameter and 4 µm in height with highly transparent glass surfaces were created. The microstructures reduced the hydrophilicity of the glass surfaces. Future studies on identifying materials compatible with glass for making masking patterns and showing good wear resistance might prove the feasibility of this method in producing structured engineering surfaces.

1. Introduction

A variety of manufacturing processes have been developed and evaluated for structuring engineering surfaces at the microscale. Applications range from modifying tribological properties, for which the relationship between friction and surface textures is researched [1,2], to inducing hydrophobicity by microstructuring surfaces [3], where contact angle measurements are used to assess the hydrophobicity or hydrophilicity of the surfaces. Convex microstructural features might offer additional advantages in this context [4]. The manufacturing processes for engineering surfaces can involve techniques such as spraying, where material is added to surfaces for generating random or hierarchical roughness [5]; these manufacturing processes can also involve removing material such as in polymers that are microstructured using photolithographic techniques [6]. The latter manufacturing process uses a masking pattern with a high-resolution microstructure attached to the substrate surface before chemical etching [7,8]. Etching is also applicable to glass substrates [9]; however, material removal might be more cost-effective and time-efficient with a mechanical process. Furthermore, influence of side-etching should be considered to obtain a high-resolution microstructure. Current mechanical structuring

processes for engineering glass surfaces lack sufficient detail at the microscale [10] owing to the brittleness of glass.

Therefore, in this research, an abrasive slurry-jet [11], more specifically a microslurry-jet (MSJ) [12], was used for microstructuring of glass surfaces. The MSJ process is a wet blasting process, where a water jet comprising small and hard particles with micrometre dimensions (slurry) was sprayed onto the substrates. Earlier studies have shown that applying the MSJ method could structure engineering surfaces (surfaces made of alloys, plastics, glass, and ceramics) to the order of nanometers in the vertical direction without the occurrence of microscopic cracks and microstructural defects on these surfaces [13,14]. Moving the MSJ nozzle during the machining process can provide continuously curved surface textures; however, the surface structures in the horizontal direction depend on the size of the nozzle, causing limitations in the machining resolution [15]. Hence, to compensate for this limitation, the combined application of a conventional photoresist masking process and the MSJ mechanical removal process was considered [16,17].

The aim of the current study was to research and assess the feasibility of using this combined masking and MSJ process for microstructuring glass surfaces in terms of the machining accuracy and changes in the hydrophobic/hydrophilic characteristics of the machined surfaces.

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Fig. 1. Micromachining of glass surface. Both the masking patterns (SU-8, sacrificial patterns) and exposed glass surface were simultaneously removed using MSJ.

Fig. 2. Design of the photomasks.

Fig. 3. MSJ processing and movements of the injection nozzle.

2. Materials and methods

2.1. Micromachining of glass surface by combined masking and MSJ process

Fig. 1 illustrates the micromachining process. Flat glass composed of SiO_2 with 13% Na_2O and 10% CaO was the material used for processing; it was ultrasonically cleaned using methanol, acetone, and ultrapure water. The organic compounds and other contaminants on the glass surface were also removed using piranha solution (a 3:1 mixture of sulfuric acid and 30% hydrogen peroxide, and up to 40% hydrogen fluoride) [18,19].

In the resist coating process, SU-8 3050, a photocurable epoxy resin

(KAYAKU MICROCHEM, Japan), was used as the photoresist [20,21]. The glass was soaked in a silane coupling agent (KBM-403, ShinEtsu, Japan) for 5 min to increase the bonding strength between glass (inorganic material) and SU-8 (organic material). The silane coupling agent contains two or more different reactive groups. One reactive group is capable of chemically bonding with an inorganic material, and the other is capable of chemically bonding with an organic material [22]. The SU-8 was coated on the glass surface, where three target thicknesses (15, 30, and 60 μm) were adjusted by using a spin coating technology. The coated SU-8 was undergone for the residual stress relaxation for 12 h at room temperature of 20–25 $^{\circ}\text{C}$.

In the ultraviolet (UV) irradiation and resist development processes, SU-8 was irradiated by UV rays passing through the photomask; the

Fig. 4. Confocal laser microscopy images of glass surfaces after the masking processes.

irradiated parts were cured and retained on the glass. The design of the photomasks is illustrated in Fig. 2. Three patterns were prepared, i.e., Type-A (diameter: 30 μm , pitch: 60 μm), Type-B (diameter: 60 μm , pitch: 120 μm), and Type-C (diameter: 90 μm , pitch: 180 μm). The pattern pitch was twice the diameter of each pattern, while the illumination intensity of UV rays was 18.7 mW/cm^2 . The light quantity for each target thickness of SU-8 (15, 30, and 60 μm) was adjusted by the exposure time; 336.6 mJ/cm^2 for 15 μm ($= 18.7 \text{ mW}/\text{cm}^2 \times 18 \text{ s}$), 467.5 mJ/cm^2 for 30 μm ($= 18.7 \text{ mW}/\text{cm}^2 \times 25 \text{ s}$), and 748.0 mJ/cm^2 for 60 μm ($= 18.7 \text{ mW}/\text{cm}^2 \times 40 \text{ s}$). The non-irradiated parts were removed through immersion in 2-acetoxy-1-methoxypropane, and thus SU-8 patterns were created on the glass surface.

In the MSJ process, both the SU-8 patterns and exposed glass surface were simultaneously removed. Fig. 3 illustrates the MSJ process and movements of the nozzle during the process (MSE-T102K-5050, Palmeseo, Japan). A slurry consisting of pure water with 3.2 wt% alumina particles was prepared. Micropolyhedral alumina particles were used, and their average diameter was 1.2 μm (WA # 8000). The slurry was sprayed vertically on the glass surfaces through an injection nozzle with a square-shaped cross-section of 1 mm width, using compressed air at 0.3 MPa. The injection nozzle could be moved parallel to the processed surface using a numerical control system. The maximum range of the processed area was 50 mm $\times$ 50 mm. The nozzle was moved to achieve a

feed rate of 3 mm/s and feed pitch of 0.1 mm. After finishing a reciprocal movement on a surface, the movement direction of the nozzle was changed by 90° to finish the next reciprocal movement on the surface. A sequence of the MSJ processing was continued until the sacrificial patterns of the SU-8 were removed by the MSJ. The glass surface with microstructures was created without post-treatment, such as removal of the SU-8 patterns.

2.2. Characterisation of processed glass

The surfaces processed through the combined masking and MSJ process were analysed using a confocal laser microscope (LEXT OLS 4100, Olympus, Japan). The shapes of the microstructures were evaluated numerically and by utilising imaging techniques. The contact angle of water was also measured using the droplet method (PCA-11, KYOWA, Japan) [27] because these types of microstructures are similar to those observed on lotus leaf surfaces [3,23,24]; these structures partially control surface characteristics, such as changes in the hydrophobic/hydrophilic features [25,26]. Before performing the measurements, all machined glasses were cleaned in an ultrasonic cleaner using ethanol, acetone, and ultrapure water.

Fig. 5. Confocal laser microscopy images of the processed glass surfaces (after the MSJ process).

Fig. 6. Relationship between removal rates of SU-8 sacrificial patterns and exposed glass surface.

3. Results and discussion

Fig. 4 shows the glass surfaces after the masking processes, with the sacrificial patterns formed as indicated in Fig. 1(4) and Fig. 2. The photoresist was precisely patterned to obtain the Type-A, Type-B, and Type-C patterns shown in Fig. 2. Confocal laser microscopy analysis confirmed that the target heights of the sacrificial patterns, namely 15, 30, and 60 μm, were achieved.

Fig. 5 shows the processed glass surface after the MSJ process (see Fig. 1(6) for a schematic representation of this step). The results show

Fig. 7. MSJ processing characteristics.

Fig. 8. Contact angles of water (θ) on each processed surface (average of 10 measurements with standard deviation). The water drop volume was $2.0 \mu\text{l}$. The drop diameters ($2r$) were also measured.

the formation of continuously curved convex microstructures with a highly transparent glass surface. The MSJ processes shown in Fig. 3 were repeated and terminated at the point where the sacrificial patterns of the SU-8 were removed by visual inspections. The number of MSJ processes was related to the height of the SU-8. The higher the SU-8 was, the longer the processing time of MSJ was. The heights of the convex structures created depend on the difference between the removal rates of SU-8 and glass (see Fig. 6). The removal ratio of glass to SU-8 by the MSJ process was estimated to be 0.0884. This indicates that the SU-8 was more easily removed by the MSJ process compared with glass. Higher

wear resistance values of masking materials should be explored when higher convex structures are requested. A structure with sharp-edge was processed to a curved surface shape by the MSJ process (Fig. 7). Therefore, the Type-A pattern with a smaller diameter became conical, and the Type-C pattern with a larger diameter had a trapezoidal shape. A missing pattern was observed when the smallest diameter and the highest SU-8 sacrificial patterns were obtained (Fig. 4(7)) after the MSJ process (Fig. 5(7)). As Type-A had a small pattern diameter, the adhesion between the glass surface and SU-8 was low. Therefore, during the MSJ processes, SU-8 separated from the glass surface at certain

locations. In this study, SU-8 was tested as the masking resin. Micro-patterns with higher resolution can be created by exploring different materials for forming sacrificial patterns, their compatibility with glass, and their wear resistance in slurry erosion.

Fig. 8 shows the contact angle of water on the glass surfaces. From the measurements, it is clear that the processed glass surface becomes less hydrophilic owing to microstructuring; this is because the contact angle increased from approximately 34° to a maximum of approximately 80°. However, hydrophilic mechanisms underlying the surface structure were not discussed because the size of convex structures was relatively large compared to the diameter of water droplets. Changing glass surfaces from hydrophilic to hydrophobic might likely involve an optimised design of the micropatterns, especially with respect to the hierarchical structuring of the glass surface [23,28].

4. Conclusions

The combined application of the photoresist masking and MSJ mechanical removal processes for creating microstructures can be directly applied for processing numerous engineering materials to create structured surfaces. The results of this work showed that this process can be applied successfully to glass. The resulting convex microstructural features up to 30 µm in diameter and 4 µm in height are beneficial in enhancing the hydrophobicity of glass surfaces. Post-treatment, such as removal of the SU-8 patterns, was not required. By exploring materials for forming masking patterns, their compatibility with glass, and their wear resistance, micropatterns with higher resolution can be achieved in future; thus, this method is promising and feasible for producing structured engineering surfaces.

Declaration of competing interest

The authors declare that they have no known competing financial interests or personal relationships that could have appeared to influence the work reported in this paper.

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